

00839.000419.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Unassigned
MAKOTO HIGASHIKAWA ET AL.	)	
	:	Group Art Unit: Not Yet Assigned
Application No.: Unassigned	)	
Division of Appln. No. 09/261,499	:	
filed March 3, 1999	)	
	:	
Filed: Herewith	)	
	:	
For: PROCESS FOR FORMING A	)	
MICROCRYSTALLINE	:	
SILICON SERIES THIN	)	
FILM AND APPARATUS	:	
SUITABLE FOR PRACTICING	)	
SAID PROCESS	:	September 5, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

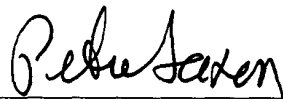
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are of record in parent Application No. 09/261,499.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No.

24947

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FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. <b>00839.000419.1</b>		APPLICATION NO. Div of Appln. No. <b>09/261,499</b>	
				APPLICANT <b>MAKOTO HIGASHIKAWA ET AL.</b>			
				FILING DATE <b>Herewith</b>		GROUP <b>Unassigned</b>	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6065425	05/00	Takaki et al.	118	723	
		5652029	07/97	Itoh	427	569	
		5766696	06/98	Itoh	427	577	
		4400409	08/83	Izu et al.	427	39	
		5677236	10/97	Saitoh et al.	437	578	
		4492736	01/85	Tanner	427	578	
		4600801	07/86	Guha et al.	427	74	
		6100466	8/00	Nishimoto	427	588	
		5720826	02/98	Hayashi et al.	427	575	
		5362684	11/94	Saito et al.	427	575	

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	9-256160	1997	Japan			Corresp. to USP 6,065,425
	JP	59-213176	1984	Japan			No
	JP	2575397	1997	Japan			No
	JP	57-195737	05/81	Japan			Eng. Abst.
	JP	59-212176	05/83	Japan			Eng. Abst.
	JP	3-6466	01/91	Japan			Abstract
	JP	57710	12/87	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
	<b>R. Flukiger, et al., "Preparation of Undoped and Doped Microcrystalline Silicon (<math>\mu\text{c-SiH}</math>) by VHR-GF for P-I-N Solar Cells, 23<sup>rd</sup> IEEE Photovoltaic Specialists Conference, 1993 (pp. 839-844).</b>

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		4920917	05/90	Nakatani, et al.	128	718	
		6025039	02/00	Yajima	427	573	
		4585537	04/86	Nakayama, et al.	204	192	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
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EXAMINER				DATE CONSIDERED			

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